

Electronic Patent Application Fee Transmittal				
Application Number:	10566425			
Filing Date:	30-Jan-2006			
Title of Invention:	Positive photoresist composition and method of forming resist pattern			
First Named Inventor/Applicant Name:	Akiyoshi Yamazaki			
Filer:	Neil S. Bartfeld/Jennifer Dolan			
Attorney Docket Number:	SHIGA7.044APC			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
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Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Statutory disclaimer	1814	1	140	140
Total in USD (\$)				140